

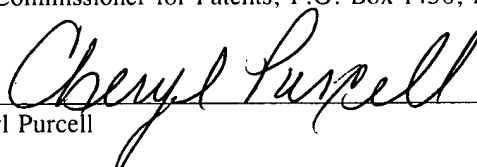
DOCKET NO: VSEA 05-99

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Charles M. McKenna et al.
Serial No: 09/602,059
Confirmation No: 9493
Filed: June 23, 2000
For: ION IMPLANTER HAVING TWO-STAGE DECELERATION
BEAMLINE
Examiner: Mary A. El-Shammaa
Art Unit: 2881

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 2 day of August, 2004.


Cheryl Purcell

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

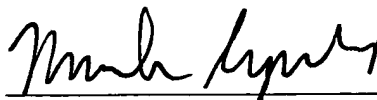
Sir:

Transmitted herewith are the following documents:

- ☒ Final Amendment
- ☒ Four-month Petition for Extension of Time
- ☒ Request for Continued Examination
- ☒ Return Receipt Postcard

If any fees are determined to be required or if there are any overpayments, Deposit Account 50-0896 may be charged or credited.

Respectfully submitted,
Charles M. McKenna et al. , Applicants

By: 
Mark A. Superko, Reg. No. 34,027
Varian Semiconductor Equipment
Associates, Inc.
35 Dory Rd.
Gloucester, Massachusetts 01930-2297
Telephone: (978) 282-5915